

**AMENDMENTS TO THE SPECIFICATION**

Please change the title to read as follows:

--Modular Device for Coating Surfaces--

Please add the Abstract as follows:

--The invention relates to a vacuum chamber for coating items in which a physical vapor deposition method is carried out. The aim of the invention is to create a vacuum chamber of the aforementioned kind which can be provided with modular cathodes. For this purpose, the vacuum chamber is provided with a plurality of receiving devices in which a plurality of cathodes each can be arranged. A first receiving device for receiving one or more cathodes is provided substantially in the center of the vacuum chamber and two additional receiving devices for receiving at least one cathode each are provided on the edges of the vacuum chamber in a door-like manner.--